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To:	Examiner Fazli Erdem	From:	Leslie S. Szivos				
Fax:	(571) 273-8300	Pages:	11 pages including cover sheet				
Phone	21	Date:	8/19/2005				
Re:	U.S. Serial No: 10/696,634 Group Art Unit: 2826 Confirmation No: 5489	CC:					
	Docket No: YOR920030394US1 (16963)						
□ Urį	gent 🗆 For Review 🗀 Please Com	nment	□ Please Reply	☐ Please Recycle			
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1.	Certificate of Transmission by Facsimile						
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3.	Amendment and Response						

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CERTIFICATE OF Applicant(s): Meikei Ieo	YC	Docket No. YOR920030394US1 (16963)									
Application No. 10/696,634	Filing Date October 29, 2003	Examiner Fazli Erdem		Group Art Unit 2826							
Invention: CMOS ON HYBRID SUBSTRATE WITH DIFFERENT CRYSTAL ORIENTATIONS USING SILICON-TO											
SILICON DIRECT WAFER BONDING											
Confirmation No.: 5489	Confirmation No.: 5489										
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AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Meikei leong et al.						Docket No. YOR920030394US1 (16963)				
Application No. 10/696,634	Filing Date October 29, 2003	Examiner Fazli Erdem		Customer No 23389	o.	Group Art Unit 2826	Confirmation No. 5489			
Invention: CMOS ON HYBRID SUBSTRATE WITH DIFFERENT CRYSTAL ORIENTATIONS USING SILICON-TO SILICON DIRECT WAFER BONDING										
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.										
	W - 1	CLAIMS AS AM								
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST #	NUMBI	ER EXTRA	RATE		ADDITIONAL FEE			
TOTAL CLAIMS	18 -	58 =				\$50.00	\$0.00			
INDEP. CLAIMS	2 -	4 =		0 :	κ	\$200.00	\$0.00			
Multiple Dependent Claims (check if applicable)							\$0.00			
		TOTAL ADDITIONAL F	EE FO	R THIS AME	ND	MENT	\$0.00			
 No additional fee is required for amendment. □ Please charge Deposit Account No. in the amount of □ A check in the amount of to cover the filing fee is enclosed. ☑ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM ☑ Any additional filing fees required under 37 C.F.R. 1.16. ☑ Any patent application processing fees under 37 CFR 1.17. □ Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. 										
Dated: August 19, 2005										
Leslie S. Szivos Registration No. 39,394 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza, Suite 300 Garden City, New York 11530 (516) 742-4343				hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" (37 CFB 1.8(a)] on (Date) Signature of Person Mailing Correspondence						
		Typed or Printed Name of Person Mailing Correspondence								

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Meikei Ieong et al.

Examiner: Fazli Erdem

Dated: August 19, 2005

Serial No: 10/696,634

Art Unit: 2826

Filed: October 29, 2003

Docket: YOR920030394US1 (16963)

For: CMOS ON HYBRID SUBSTRATE

WITH DIFFERENT CRYSTAL

ORIENTATIONS USING SILICON-TO SILICON DIRECT WAFER BONDING

Confirmation No.: 5489

Mail Stop Amendment Commissioner for Patents United States Patent Office Alexandria, VA 23313-1450

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action dated August 11, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: August 19, 2005

Lessie S. Szivos